

APPLICATION DATA SHEET

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Application Type:

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Title of Invention:

METHOD FOR FABRICATING THIN-FILM TRANSISTOR

Legal Representative:

Attorney or Agent:

Eric J. Robinson

Registration Number:

38285

Attorney or Agent:

Jeffrey L. Costellia

Registration Number:

35483

Attorney or Agent:

Donald R. Studebaker

Registration Number:

32815

Attorney or Agent:

Jason H. Vick

Registration Number:

45285

Attorney or Agent:

Charles M. Leedom

Registration Number:

26477

Attorney or Agent:

David S. Safran

Registration Number:

27997

Customer Number Correspondence Address:

22204

22204

Continuity Data:

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Priority Claimed

Assignee (Publish): Semiconductor Energy Laboratory Co., Ltd.

398, Hase,

Atsugi-shi 243-0036 Kanagawa-ken JP

INVENTOR(s):

Primary Citizenship:

JP

Given Name:

Hongyong

Family Name:

ZHANG

Residence City:

Yamato-shi

Residence Country:

JP

Address:

Paresu Miyagami 302, 1-10-15, Fukamidai,

Yamato-shi Kanagawa, 242 JP